



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: VIRBULIS ET AL - 1

SERIAL NO.: 10/053,446 GROUP: 1765

FILED: JANUARY 17, 2002

FOR: PROCESS AND APPARATUS FOR PRODUCING A SILICON SINGLE CRYSTAL

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT
OF DR. WOLFGANG STAUDACHER

BOX NON-FEE AMENDMENT
Assistant Commissioner of Patents
Washington, D.C. 20231

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TC 1700

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached Information Disclosure Statement, duly signed by Dr. Wolfgang Staudacher, the Office Action of the German Patent and Trademark Office, and the three (3) references listed on the enclosed Form PTO-1449 and attached thereto.

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The relevance of these references is that they are cited in the Specification and in the Office Action of the German Patent and Trademark Office, and may be material to the examination of the application.

Since this Information Disclosure Statement is being filed

prior to a first Office Action, it is believed that no fee is due. However, if it is determined that a fee is due, the Commissioner is hereby authorized to charge, or to credit any over payment, to our Deposit Account Number 03-2468.

It is respectfully requested that this Information Disclosure Statement be considered and placed into the application file.

Respectfully submitted,

VIRBULIS ET AL- 1

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Papers Sent:

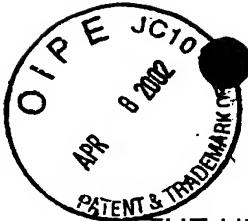
Preliminary Amendment

Enclosures:

- (1) Revised FIG. 4;
- (2) Submission of Information Disclosure Statement of Dr. Wolfgang Staudacher;
- (3) Information Disclosure Statement of Dr. Wolfgang Staudacher;
- (4) Office Action of the German Patent and Trademark Office;
- (5) PTO-form 1449 w/copies of three (3) references.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231, on April 3, 2002.

Lisa L. Vulpis
Lisa L. Vulpis



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6
S-14-02

In re application of:

VIRBULIS ET AL. -1

Serial Number: 10/053,446

Group Art Unit: 1765

Filed: January 17, 2002

For: PROCESS AND APPARATUS FOR PRODUCING A SILICON SINGLE CRYSTAL

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Information Disclosure Statement

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Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed application and in the Office Action of the German Patent and Trademark Office and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

GB 1 347 108 is already in English language.

For DE 37 01 733 an English Derwent Abstract is enclosed.

Signed this 13th day of March, 2002.

Dr. Wolfgang Staudacher